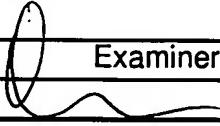


ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention	A METHOD AND SYSTEM FOR FORMING A PASSIVATED METAL LAYER						
Application Number:	10 / 711717						
Confirmation Number:	—						
First Named Applicant:	Hideaki Yamasaki						
Attorney Docket Number:	RAJ025						
Art Unit:	1762						
Examiner:	—						
Search string:	(6238737).pn						
US Patent Documents							
Note: Applicant is not required to submit a paper copy of cited US Patent Documents							
Init	Cite. No.	Patent No.	Date	Patentee	Kind	Class	Subclass
W	1	6238737	2001-05-29	Chan et al.	B1	427	255.18
Remarks							
Note: Remarks are not for responding to an office action.							
In accordance with the duty of candor and good faith imposed by 37 C.F.R. 1.56 and means of complying therewith according to 37 C.F.R. 1.97 and 1.98, the references listed on this Information Disclosure Statement are called to the attention of the United States Patent and Trademark Office in connection with the above-identified patent application. No representation is made that the cited art is the only art or that the cited art represents the best art. The Examiner is urged to consider all of the cited documents and to make an independent evaluation of the teachings and materiality of each. If any additional fees are necessary to complete this communication, please apply them to Deposit Account No. 23-3000.							
Signature							
Examiner Name				Date			
				9/26/05			